The WHS-P3 is a manual wafer presenter designed to simultaneously lift a set of five wafers 50% up from the bottom of the cassette, enabling operators to safely remove a wafer without the risk of scratching neighboring wafers in the cassette. Available for 150 mm (6"), 200 mm (8"), and compatible with 125 mm wafers (WHS-P3-601 model), this presenter offers an efficient solution for wafer handling in semiconductor fabs.

By lifting wafer sets (e.g., 1:6:11:16:21 or 2:7:12:17:22), the WHS-P3 allows operators to easily access individual wafers without needing to manually manipulate them inside the cassette, significantly reducing the risk of wafer damage, scratches, and contamination.

Constructed from antistatic materials, the WHS-P3 ensures optimal ESD protection, meeting ISO 4









(FS209E Class 10) cleanroom standards for semiconductor processing environments.

The WHS-P3 is designed with precision and durability in mind, ensuring the highest level of protection for your wafers during inspection, sorting, and transfer operations. Its safe edge-handling lift arm and SEMI compliance make it a reliable tool for cleanroom operations.

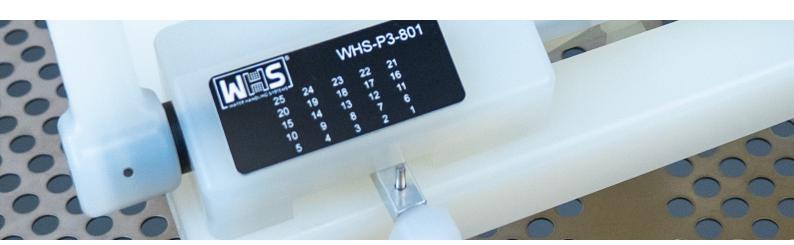
Manufactured in an ISO9001 certified facility and CE certified, the WHS-P3 is an ideal solution for reducing wafer defects and yield loss, enhancing operational efficiency in semiconductor wafer handling processes.

## **FEATURES AND ADVANTAGES**

- Lifts five wafers simultaneously for safe handling
- · Reduces wafer scratching and contamination risks
- Available for 150, 200, and 125 mm wafers
- Antistatic construction, ISO 4 cleanroom compliant
- Safe edge-handling lift arms

## **5-WAFER PRESENTER**

ITEM	SPECIFICATIONS	
Sizes	125/150 or 200 mm	
Materials, lift comb	Natural polypropylene	
Materials, wafer comb	Antistatic polyoxymethylene	
Materials, structure	Natural / white polypropylene	
Cleanliness	ISO 4 (Class 10 FS209E)	
*** NOTE: Please specify cassette model number when ordering ***		



## **ORDERING INFORMATION**

WHS-P3 -	601		
CODE	MODEL	MODEL	
	601	Manual 5-wafer lift presenter, 150 mm (6")	
	801	Manual 5-wafer lift presenter, 200 mm (8")	

